



MIT. 9922

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Menon et al.

SERIAL NO: 10/624,316

FILED: July 21, 2003

FOR: SYSTEM AND METHOD FOR MASKLESS LITHOGRAPHY USING  
AN ARRAY OF IMPROVED DIFFRACTIVE FOCUSING ELEMENTS

Assistant Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
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Sir:

**CHANGE OF CORRESPONDENCE ADDRESS**

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Issue fee

*Deborah M. Costello*  
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8-26-05  
Date